

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT BY APPLICANT(S)

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Docket No.: 6495-0108WOUS Applicant: Peter Gravesen, et al. Title: Tactile Sensor Element and

Sensor Array

U.S. Serial No.: 10/538,260 U.S. Filing Date: Group Art Unit: 06/09/2005

2855

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